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APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP02/13477 12/25/2002

**** FOREIGN APPLICATIONS *******

JAPAN 2001-394791 12/26/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 20	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 10
Verified and Acknowledged	Examiner's Signature: <i>[Signature]</i> Initials: <i>FLH</i>				

ADDRESS

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TITLE

Method for vanishing defects in single crystal silicon and single crystal silicon

FILING FEE RECEIVED 1522	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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